

Notice of References Cited	Application/Control No. 10/550,009		Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner <i>V. J. D.</i> Kamran Afshar 571-272-7796		Art Unit 2617	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US- H0,002,051	11-2002	Zhu et al. <i>H2051</i>	370/395.21
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